

#### PATENT APPLICATION

# THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88663

Tsuyoshi NAKANO, et al.

Appln. No.: 10/540,515

Group Art Unit: Unassigned

Confirmation No.: Unassigned

Examiner: Unassigned

Filed: June 23, 2005

For:

COMPOUND SEMICONDUCTOR EPITAXIAL SUBSTRATE AND METHOD FOR

MANUFACTURING THE SAME

### **PRELIMINARY AMENDMENT**

#### MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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